Application No.: 10/614,451 Docket No.: 07200/032001

AMENDMENTS TO THE CLAIMS

Please amend the claims as follows.

- 1. (Currently Amended) A resist stripping equipment, comprising:
 - a first stripping solution tank in which resist stripping solution is preserved;
 - a <u>plurality of first</u> resist stripping chambers in which a substrate covered with resist is accommodated, wherein the <u>plurality of resist stripping chambers are provided in communication with each other, and wherein the substrate is supplied from a first stage resist stripping chamber to a next stage resist stripping chamber;</u>
 - a first spray which is connected to the first stripping solution tank and sprays the resist stripping solution into the resist in the first resist stripping chamber;
 - a first solution line which supplies the sprayed resist stripping solution from the first resist stripping chamber to the first resist stripping tank;
 - a gas line which supplies a mixed gas containing a resist stripping solution component from the first resist stripping chamber to outside;
 - a gas/liquid separation block which is connected to the gas line, and which separates the resist stripping solution component from the introduced mixed gas;
 - a second resist stripping chamber which is connected to the first resist stripping chamber and whereto the substrate is supplied from the first resist stripping chamber;
 - a second stripping solution tank in which resist stripping solution is preserved;
 - a second spray which is connected to the second stripping solution tank and sprays the resist stripping solution into the resist in the second resist stripping chamber;
 - a second solution line which supplies the sprayed resist stripping solution from the second resist stripping chamber to the second resist stripping tank;
 - a recovered resist stripping solution line which is connected to the gas/liquid separation block and supplies the separated resist stripping solution component to the second stripping solution tank; and

127175

Application No.: 10/614,451 Docket No.: 07200/032001

a line which is connected to the second stripping solution tank and supplies the resist stripping solution to the first stripping solution tank;

- a rinse chamber provided in communication with a last stage resist stripping chamber, wherein the substrate is supplied from the last stage resist stripping chamber to the rinse chamber, and wherein the rinse chamber is supplied with water;
- a damper which is connected on the gas line;
- a pressure switch which monitors an inner pressure of the rinse chamber and transmits to the damper a value travel signal; and
- an inert gas supply unit which is connected to the rinse chamber and supplies inert gas into the rinse chamber.
- 2. (Previously Presented) The resist stripping equipment of claim 1, further comprising:
 - a separated gas supply unit which receives gas separated from the resist stripping solution component in the liquid/gas separation block and supplies the gas to a gas spout unit,
 - wherein at least one of the resist stripping chambers includes a the gas spout unit.
- 3. (Original) The resist stripping equipment of claim 2, wherein the gas spout unit is disposed facing the substrate.
- 4. (Cancelled)
- 5. (Cancelled)
- 6. (Cancelled)
- 7. (New) A resist stripping equipment, comprising:
 - a first stripping solution tank in which resist stripping solution is preserved;
 - a plurality of resist stripping chamber in which a substrate covered with resist is accommodated, wherein the plurality of resist stripping chambers are provided in communication with each other, and wherein the substrate is supplied from a first stage resist stripping chamber to a next stage resist stripping chamber;

127175 4

Application No.: 10/614,451 Docket No.: 07200/032001

a first spray which is connected to the first stripping solution tank and sprays the resist stripping solution into the resist in the first resist stripping chamber;

- a first solution line which supplies the sprayed resist stripping solution from the first resist stripping chamber to the first resist stripping tank;
- a gas line which supplies a mixed gas containing a resist stripping solution component from the first resist stripping chamber to outside;
- a gas/liquid separation block which is connected to the gas line, and which separates the resist stripping solution component from the introduced mixed gas;
- a second stripping solution tank in which resist stripping solution is preserved;
- a second spray which is connected to the second stripping solution tank and sprays the resist stripping solution into the resist in the second resist stripping chamber;
- a second solution line which supplies the sprayed resist stripping solution from the second resist stripping chamber to the second resist stripping tank;
- a recovered resist stripping solution line which is connected to the gas/liquid separation block and supplies the separated resist stripping solution component to the second stripping solution tank;
- a line which is connected to the second stripping solution tank and supplies the resist stripping solution to the first stripping solution tank;
- a rinse chamber provided in communication with a last stage resist stripping chamber, wherein the substrate is supplied from the last stage resist stripping chamber to the rinse chamber, and wherein the rinse chamber is supplied with water;
- a damper which is connected on the gas line;
- a pressure switch which monitors an inner pressure of the last stage resist stripping chamber and transmits to the damper a value travel signal; and
- an inert gas supply unit which is connected to the last stage resist stripping chamber and supplies inert gas into the last stage resist stripping chamber.

127175 5